ABSTRACT

The present invention provides a transferring method for transferring a plurality of microstructures provided on a base member from the base member by virtue of laser irradiation, in which at least a space between the microstructures adjacent to each other is filled with a polymer material, the transferring method includes: a first laser-irradiation step of irradiating the microstructures with a laser through the base member; and a second laser-irradiation step of irradiating the polymer material with a laser through the base member, and in the first laser-irradiation step, regions corresponding to the microstructures are irradiated with the laser directed to the microstructures. This can prevent occurrence of chipping or cracking in the microstructures when the microstructures are transferred from the base member.